



PATENT  
81784.0301

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Mitsuru OKIGAWA

Serial No: 10/773,088

Filed: February 5, 2004

For: SEMICONDUCTOR INTEGRATED DEVICE  
INCLUDING SUPPORT SUBSTRATE  
FASTENED USING RESIN, AND  
MANUFACTURING METHOD THEREOF

Art Unit: 2891

Examiner: Luan C. Thai

**PETITION FOR EXTENSION OF TIME**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence  
is being deposited with the United States  
Postal Service with sufficient postage as  
first class mail in an envelope addressed  
to:

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450, on

April 17, 2006

Date of Deposit

John P. Scherlacher, Reg. No. 23,009

Name

*John P. Scherlacher* 04/17/06

Signature

Date

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the  
Commissioner for a one-month extension of time extending to April 21, 2006, the  
period for response to the Final Office Action dated December 21, 2005. Please  
charge the fee of \$120 for this extension to Deposit Account No. 50-1314. The  
responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account  
No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,  
HOGAN & HARTSON L.L.P.

Date: April 17, 2006

By: *John P. Scherlacher*  
John P. Scherlacher  
Registration No. 23,009  
Attorney for Applicant(s)

500 South Grand Avenue, Suite 1900  
Los Angeles, California 90071  
Phone: 213-337-6700  
Fax: 213-337-6701

10773088

501314

04/20/2006 HDETA1

120.00 DA

02 FC:1251